

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Kazutoshi KAJI, et al. : Confirmation Number:
Serial No.: : Group Art Unit:
Filed: March 24, 2004 : Examiner:
For: ELECTRON MICROSCOPE

INFORMATION DISCLOSURE STATEMENT

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P.O. Box 1450
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Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

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Respectfully submitted,

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| INFORMATION DISCLOSURE CITATION IN AN APPLICATION | | | ATTY. DOCKET NO. 62807-175 | | SERIAL NO. | |
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| | | | APPLICANT Kazutoshi KAJI, et al. | | | |
| (PTO-1449) | | | FILING DATE March 24 2004 | GROUP | | |
| U.S. PATENT DOCUMENTS | | | | | | |
| EXAMINER'S INITIALS | CITE NO. | Document Number Number-Kind Code ₂ (<i>if known</i>) | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear | |
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| FOREIGN PATENT DOCUMENTS | | | | | | |
| EXAMINER'S INITIALS | CITE NO. | Foreign Patent Document Country Code ₃ -Number +-Kind Codes (<i>if known</i>) | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines Where Relevant Figures Appear | Translation |
| | | JP 2001-93459A (w/ English Abstract) | 04/06/2001 | HITACHI LTD. | | Yes |
| | | JP 11-224639 (w/ English Abstract) | 08/17/1999 | HITACHI LTD., HITACHI INSTR. ENG. CO., LTD. | | No |
| | | JP 52-27349 (w/ English Abstract) | 03/01/1977 | SIEMENS AG | | |
| | | JP 2001-307672 A (w/ English Abstract) | 11/02/2001 | HITACHI LTD. | | |
| | | JP 2002-157973 A (w/ English Abstract) | 05/31/2002 | HITACHI LTD. | | |
| | | JP 2003-151478 A (w/ English Abstract) | 05/23/2003 | HITACHI HIGH-TECHNOLOGIES CORP. | | |
| | | WO00/41206 (w/ English Abstract) | 07/13/2000 | HITACHI LTD. | | |
| OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | |
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